IN THE UNITED STATES PATENT AND TRADEMARK OFFICE.

Applicant(s): Bernd SZYSZKA et al.

Group Art Unit: 1795

Appln, No. : 10/583,124

Examiner: Rodney G. MCDONALD

I.A. Filed

: November 29, 2004

Confirmation No.: 1797

For

: METHOD AND DEVICE FOR MAGNETRON SPUTTERING

REQUEST FOR RECONSIDERATION UNDER 37 CFR 1.111 AND INTERVIEW SUMMARY

Commissioner for Patents United States Patent and Trademark Office Customer Service Window, Mail Stop Amendment Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

In response to the Office Action dated November 18, 2008, Applicants respectfully request reconsideration in view of the following.

A listing of claims begins on page 2.

Remarks begin on page 6.

If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to Deposit Account No. 19-0089.